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Method For Depositing Rare-Earth Boride Onto a Substrate

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Disclosed is a method for depositing rare-earth boride onto the surface of a substrate which is submerged in an organic solution of borane and a rare-earth halide. Application of electromagnetic radiation, preferably in the visible wavelength range, near the surface of the submerged substrate drives the formation and deposition of rare-earth boride onto a substrate.
RESERVOIR OF CHEMICAL

LIGHT INDUCED CHEMISTRY

WASTE MATERIALS TO BE RECOVERED AND REUSED

FIG. 1

FIG. 2
FIG. 3a

Intensity vs. 2θ (degrees)

(110) (111) (210) (220) (221)

FIG. 3b

Intensity vs. 2θ (degrees)

GdB₄ (001) GdB₄ (200) GdB₄ (210) Gd₂B₂ (101) GdB₄ (310) GdB₂ (221) GdB₄ (002) GdB₂ (330) GdB₄ (530)

GLASS SUBSTRATE
METHOD FOR DEPOSITING RARE-EARTH BORIDE ONTO A SUBSTRATE

TECHNICAL FIELD

The present invention relates to the deposition of materials onto substrates, and more particularly is a method for depositing rare-earth borides onto the surface of a substrate which is submerged in an organic solution of borane and a rare-earth halide, said deposition being driven by application of electromagnetic radiation.

BACKGROUND

While not limiting, a particularly relevant application of the present invention is in the fabrication of a variety of electron emitting electrodes and gas-discharge plasma display systems which comprise cathode(s) and electrically excitable gas(es). Fabrication of plasma display systems requires that cathode material(s) which can emit electrons be caused to be present in desired patterns on substrates which are situated in close proximity to said electrically excitable gas(es). Preferably said cathode material(s) should have a low work function such that electrons can be easily emitted therefrom in use, and said electrically excitable gas(es) should be capable of providing desired, (eg. visible), electromagnetic wavelengths when electrical discharge is caused to occur therein by application of electric potential to closely situated cathodes.

Approaches to improving gas-discharge plasma displays include:

a. development and use of improved cathode material(s);

b. development and practice of improved cathode material deposition;

c. development and use of improved electrically excitable gas(es).

While the development and use of improved electrically excitable gas(es) is a very viable and worthy approach to improving operation of gas discharge display systems, the present invention is focused on development and use of improved cathode material(s) and development and practice of improved cathode material(s) deposition onto substrates which can be adapted to comprise plasma discharge displays.

In view of the focus of the present invention, it is noted that various approaches to fabricating substrates which have cathode material(s) present thereon in desired patterns, have been investigated by previous researchers. Such techniques include:

a. screen printing;

b. plasma spray deposition;

c. vacuum deposition by sputtering or evaporation;

d. cluster-assisted deposition;

e. light-induced deposition from solution.

The present invention was arrived at by experimentation in the area of light-induced deposition of cathode material(s) from solution, (preferably organic solvent based), and the present invention is founded in practice of a method and the results of the practice thereof.

A search of Patents focused upon gas-discharge plasma displays provided a Patent to Kolwa et al., U.S. Pat. No. 5,159,238, which describes a gas discharge panel with a plurality of electrically conductive oxide cathode electrodes formed from, for instance, lanthanum, chromite, lanthanum calcium chromite, aluminum doped zinc oxide, or antimony-doped tin oxide.

Continuing, and of somewhat more relevance, a Patent to Lafferty, U.S. Pat. No. 2,639,399, and a Patent to Kauer, U.S. Pat. No., 3,399,321 disclose that rare-earth hexaborides have low work functions and are very suitable to application in electron emitter and filament applications. A Patent to Yokono et al., U.S. Pat. No. 4,599,076 describes production of a discharge display involving the cathode forming steps of applying a paste prepared by mixing LaB₆ powder with alkali glass powder in proportion of 20-40% by weight to a base electrode, then burning the paste and then activating the paste by gas discharge with large current after an exhaustion step. A similar process leading to a similar result is also described in U.S. Pat. No. 4,600,397 to Kawakubo et al. A Patent to Kamegaya et al., U.S. Pat. No. 4,393,326 describes a gas discharge panel with an electrode comprised of a metal layer, (eg. Fe and Ni), and a metal compound layer, (eg. alkaline earth metal oxide or sulphide and rare-earth metal hexaboride), which are formed by a plasma spray technique. Another Patent which describes use of a rare-earth hexaboride such as LaB₆, in forming cathodes in a plasma discharge display is U.S. Pat. No. 4,727,287 to Aida et al. Another Patent, U.S. Pat. No. 5,277,932 to Spencer, describes application of chemical vapor deposition techniques to deposit metal boride films onto substrates utilizing metal borane cluster compounds as a precursor.

While this method is successful, it does not lend itself well to either selective area depositions, or to depositions in large scale area manufacturing where substrates can have dimensions of several inches.

The above Patents show that the use of low work function rare-earth hexaborides to form cathodes in electron emitter, filament and gas plasma displays is not new, and that various techniques exist for forming such rare-earth containing cathodes. However, no known Patent describes the formation of rare-earth containing cathodes by a method comprising light-induced deposition from solution. This is even more so where the solution is organic solvent based. It is noted that organic-based solvent based solutions, (eg. those containing methanol, nitriles or amides), as opposed to aqueous solutions, absorb wavelengths in the ultraviolet and are therefore often overlooked in the practice of light-induced deposition from solution.

Additional searching performed with an eye to identifying the application of light-induced deposition (LISD) from solution in formation of rare-earth containing electrodes provided very little. A Patent to Liepins, U.S. Pat. No. 4,464,416 describes a procedure which is purported to be applicable to forming a metallic coating on a polymeric substrate, comprising contacting the polymeric substrate with a fluid containing a metal compound at a temperature below 150 degrees centigrade for a time sufficient for the metal to be sorbed into the substrate, and then subjecting the substrate to a low pressure plasma. A perhaps somewhat more relevant Patent is U.S. Pat. No. 3,484,263 to Kushihashi et al. in which a process for forming a layer of semi-transparent gold on the surface of glass is described as comprising the steps of containing a water-soluble gold salt and a reducing agent in contact with said glass while subjecting said glass to short wave rays in the range of 250 to 500 Nanometers, with the improvement being that the solution is maintained at a temperature of not more than 10 degrees centigrade. Another Patent, U.S. Pat. No. 4,511,595 to Iinoue, describes the deposition of a metal to a substrate from a typically flowing solution, wherein a laser beam is directed onto the substrate over a localized area, to activate an interface between said localized area and said solution. A Patent to Braren et al., U.S. Pat. No. 5,260,108 describes deposition of a metal such as palladium onto a substrate such as a polycrystalline, silicon dioxide, tantalum oxide or polyeth-
polyhedrally by contacting the substrate surface with a solution of the metal, and then exposing the surface of the substrate to laser radiation characterized by a wavelength absorbable by the substrate and a power density and fluence effective to release electrons to promote deposition of the metal onto the substrate without thermal activation of the substrate or the solution. Finally, a Patent to van der Putten et al., U.S. Patent No. 5,059,449 describes depositing a noble metal such as platinum from a salt solution thereof, onto a substrate which can be an insulator, semiconductor or conductor, by use of a laser beam. The solution is described as consisting essentially of a solvent selected from the group consisting of ammonia, a cyclohexanone and an amine, and typical metals which can be deposited are described as Pd, Pt, Rh, Ir, Ru and Ag. Application of the laser through masking to define areas of metal deposition is also described.

Articles of which the inventors are aware include:

A paper which describes the low work function of rare-earth metal borides is titled "Thermionic Emission Properties of LaB\(_6\) and CeB\(_6\) In Connection With Their Surface States, Examination By XPS, Auger Spectroscopy And The Kelvin Method", Berrada et al., Surface Science, 72, 177 (1978).

Application of rare-earth metal borides in thermionic emitters is discussed in:

"Microcircuits By Electron Beam", Broers et al., Sci. Am. 227, 34 (1972);

"Lanthanum Hexaboride Electron Emitter", Ahmed et al., J. Appl. Phys. 43, 2185 (1972);

"Electron-Beam Fabrication", Miller et al., Solid State Technology, 16, 25 (July 1973);


Articles which describe reaction of nido-decaborane and metal chlorides and subsequent chemical vapor deposition (CVD) of gadolinium hexaboride are:


Similar rare-earth boride deposition, (where gadolinium was not the rare-earth involved), is discussed in:


Selective area deposition of copper metal films from solution is described in:


"Material Deposition", Bauerle, Chemical Processing with Lasers", ED. Queisser, Springer Verlag (1986);

"Surface Processing Leading To Carbon Contamination Of Photochemically Deposited Copper Films", Houle et al., J. Vac. Sci Technol., A 4(6) 2452 (November/December 1986);

A reference which describes vacuum reactor deposition of nickel boride is:

“Chemical Vapor Deposition Precursor Chemistry. 3. Formation And Characterization Of Crystalline Nickel Boride Thin Films From The Cluster-Assisted Deposition Of Polyhedral Borane Compounds”, Kher et al., Chem. Mater., 4, 538 (1992);

A reference which describes fabrication of bulk gadolinium borides (an amorphous boron) as a result of thermalysis of a molecular precursor Gd3(B10H14)2 is:


Even in view of the large number of references, there remains need for additional, simple and efficient, techniques for selective area laser induced deposition of rare-earth borides onto substrates.

DISCLOSURE OF THE INVENTION

The present invention is primarily a method of depositing rare-earth boride, (eg. hexaboride), onto the surface of a substrate. Typical practice of said method begins with the dissolving borane and at least one rare-earth halide in an organic solvent, followed by providing and placing a substrate into said solution, so that a surface of said substrate is submerged but accessible by electromagnetic radiation. Next, a source of electromagnetic radiation is caused to expose the surface of said substrate to electromagnetic radiation, through said solution of borane and at least one rare-earth halide in said organic solvent. As a result at least one rare-earth halide in the vicinity of said substrate surface is fragmented into free halide and free rare-earth components and said free halide fractures said borane. Components of said fractured borane then combine with the free rare-earth to form rare-earth boride which deposits on said surface of said substrate.

The organic solvent is preferably comprised of at least one selection from the group consisting of: (methanol, THF, hexane, ether, benzene, a nitrile and an amide).

While not limiting, the substrate can be made of sodium glass. It should be appreciated in particular, that a deposited rare-earth boride need not be lattice matched to a substrate to achieve a very good, textured, rear-earth boride film deposition thereupon.

The source of electromagnetic radiation used to expose the surface of said substrate to electromagnetic radiation can be a laser, or a source of essentially white light which is passed through filtering means to provide favored wavelengths, which are in the visible range where hv=2.4 eV. It is noted that use of wavelengths in the visible range greatly diminishes problem of wavelength absorption, which can be very significant where organic solvents are utilized. It is also noted that a favored source of electromagnetic radiation in the experimental work performed by the inventors to date is an Argon Ion Laser (1-90 Coherent).

Favored practice is to deposit rare-earth boride onto the surface of a substrate in patterns which are effected by exposing the surface of said substrate to electromagnetic radiation through an electromagnetic masking means placed between said source of electromagnetic radiation and the surface of said substrate.

While most experimental work to date has been done utilizing Gadolinium (Gd), essentially any rare-earth halide can be utilized in practice of the present invention, (eg. Sc, Y, La, Ce, Pr, Nd, Pm, Sm, Eu, Gd, Tb, Dy, Ho, Er, Tm, Yb, and Lu), and a preferred, but not limiting halide is chloride. In addition, it is noted that a preferred end result is deposition of rare-earth hexaboride on the surface of a substrate.

An exemplary method of depositing GdB6 onto the surface of a substrate comprising the steps of:

a. dissolving B10H14 and said GdCl3 in an organic solvent comprising methanol;

b. providing and placing a substrate in said solution of B10H14 and said GdCl3, in said organic solvent comprising methanol, so that a surface of said substrate is submerged, but accessible by electromagnetic radiation through said solution of B10H14 and said GdCl3 in said organic solvent which includes at least one selection from the group consisting of: (methanol, THF, hexane, ether, benzene, nitrile and amine);

c. providing a source of electromagnetic radiation and exposing the surface of said substrate to electromagnetic radiation through said solution of B10H14 and said GdCl3 in said organic solvent comprising methanol, from said source of electromagnetic radiation; and

d. exposing the surface of said substrate to electromagnetic radiation through said solution of B10H14 and said GdCl3 in said organic solvent comprising methanol, from said source of electromagnetic radiation; such that said GdCl3 in the vicinity of said substrate surface is fragmented into free chloride and free Gd components, with the result being that said free chloride fractures said B10H14 with the further result being that components of said fractured B10H14 combine with Gd to form GdB6+(B10−xH14+xCl−x+HCl), which GdB6 deposits on said surface of said substrate.

The present invention will be better understood by reference to the Detailed Description Section of this Disclosure in conjunction with appropriate reference to the Drawings.

SUMMARY OF THE INVENTION

It is therefore a primary purpose of the present invention to teach a method for depositing rare-earth boride onto the surface of a substrate which is submerged in an organic solution of borane and a rare-earth halide, via application of electromagnetic radiation to the surface of the submerged substrate.

It is another purpose of the present invention to describe a product which results from practice of the method of the present invention.

It is yet another purpose of the present invention to identify at least one selection from the group consisting of: (methanol, THF, hexane, ether, benzene, nitrile and amine) as an appropriate organic solvent for use in practicing the method of the present invention.

It is still yet another purpose of the present invention to identify sodium glass as an appropriate substrate for use in practicing the method of the present invention.

It is another purpose yet of the present invention to identify appropriate sources of electromagnetic radiation used to expose the surface of said substrate to electromagnetic radiation can be a laser, or a source of essentially white light which is passed through filtering means to provide favored wavelengths, which are in the visible range where hv=2.4 eV.

It is another purpose yet of the present invention to disclose that favored practice is to deposit rare-earth boride onto the surface of a substrate in patterns which are effected by exposing the surface of said substrate to electromagnetic radiation through an electromagnetic masking means placed between said source of electromagnetic radiation and the surface of said substrate.
It is another purpose of the present invention to disclose that the method of the present invention can be practiced with any of the rare-earths: (Sc, Y, La, Ce, Pr, Nd, Sm, Eu, Gd, Tb, Dy, Ho, Er, Tm, Yb, and Lu).

It is yet another purpose of the present invention to disclose that a preferred halide for use in practice of the present invention is chloride. Such as used in DC plasma discharge display systems and it is believed that textured films provide improved electrode fatigue properties. The Gadolinium Hexaboride (GdB₆) films were grown on non-crystalline sodium glass, such as used in DC plasma discharge display systems and it is emphasized that no lattice matching between said Gadolinium Hexaboride (GdB₆) and the sodium glass was present.

FIG. 3b shows X-ray Diffraction Patterns from Gadolinium sub-borides (GdB₆) and (GdB₅) on a glass substrate, along with the similar results from the glass substrate prior to deposition. These films showed trace amounts of chlorine present which is consistent with the presence of the identified Gadolinium sub-borides. Similar Lanthanum borides have also been fabricated.

It is another purpose of the present invention to disclose clearly indicates that the films grown from solution are textured. It is noted that films of Gadolinium Hexaboride (GdB₆) grown in a vacuum reactor typically show far less texturing. It is believed that textured films provide improved electrode fatigue properties. The Gadolinium Hexaboride (GdB₆) films were grown on non-crystalline sodium glass, such as used in DC plasma discharge display systems and it is emphasized that no lattice matching between said Gadolinium Hexaboride (GdB₆) and the sodium glass was present.

Additional films were deposited utilizing electromagnetic radiation in the ultraviolet. Where this was done the methanol content of the solution was reduced to less than 1%. The resulting films showed characteristics of nucleation sites. It is noted that methanol is a necessary solvent component for the dissolution of gadolinium chloride, and that the content of methanol must be reduced where ultraviolet wavelengths are utilized as methanol absorbs UV wavelengths).

The results of the present laser initiated deposition from solution procedure suggests that the deposition chemistry is similar to that associated with use of high temperature vacuum reactor. It is believed that the chemical reaction for the gadolinium borides during deposition from solution can be written as:

\[
\text{GdCl}_3 + \text{B}_3\text{H}_6 \rightarrow \text{GdB}_5 + \text{B}_{10} + \text{H}_3\text{Cl}_3 + \text{HCl}
\]

It is believed that a key chemical intermediate is of the form:

\[
\text{RE}_2\text{B}_3\text{H}_{10}
\]

(where "RE" = Rare Earth), and is a part of the thin film deposition process. The fabrication of the bulk gadolinium borides (and amorphous boron), has been undertaken from the thermolysis of said molecular \(\text{Gd}_2\text{B}_3\text{H}_{10}\) precursor. The dominant gadolinium borides in this pyrolysis reaction are \(\text{GdB}_4\) and \(\text{GdB}_6\), as is also the case in the solution deposition reported here.

Laser-induced deposition of gadolinium borides from solution has been shown to be effective and simple. The mechanism of Laser Induced Solution Deposition (LISD) clearly resembles that of Chemical Vapor Deposition (CVD) in the gas phase. However, unlike gas phase deposition, (e.g. CVD and PECVD), deposition from solution is compatible with thin film formation on thermally sensitive substrates because of the large thermal sink of the solvent/solute mixture.

It is noted that the mechanism of inducing deposition material reducing electrons at the surface of a substrate onto which a rare-earth boride is to be deposited, such as described in the previously referenced Patent to Inoue, (U.S. Pat. No. 4,511,585), which describes the deposition of a metal onto a substrate from a typically flowing solution, wherein a laser beam is directed onto the substrate over a localized area, to activate an interface between said localized
area and said solution, might play a role similar to that in the case where a metal is reduced onto the surface of a substrate.

It should also be appreciated that the (LISD) technique permits one undertake recovery of unused metals and source compounds, and volatility, toxicity and safety issues, common to (CVD) processes, are diminished. Further, the fact that present invention rare-earth boride film deposition occurs best where visible range wavelengths are utilized in the deposition process, means that the present invention process for deposition of rare-earth hexaborides onto substrates can more easily be adapted to industrial scale environments where conventional visible light sources are commonly available.

Having hereby disclosed the subject matter of the present invention, it should be obvious that many modifications, substitutions, and variations of the present invention are possible in view of the teachings. It is therefore to be understood that the invention may be practiced other than as specifically described, and should be limited in its breadth and scope only by the Claims.

We claim:

1. A method of depositing rare-earth boride onto the surface of a substrate comprising the steps of:
   a. dissolving borane and at least one rare-earth halide in an organic solvent;
   b. providing and placing a substrate in said solution of borane and at least one rare-earth halide in said organic solvent, so that a surface of said substrate is submerged but accessible by electromagnetic radiation;
   c. providing a source of electromagnetic radiation and exposing the surface of said substrate to electromagnetic radiation through said solution of borane and at least one rare earth halide in said organic solvent, from said provided source of electromagnetic radiation; such that said at least one rare-earth halide in the vicinity of said substrate surface is fragmented into free halide and free rare-earth components, with the result being that said free halide fractures said borane, with the further result being that components of said fractured borane combine with free rare-earth to form rare-earth boride which deposits on said surface of said substrate.

2. A method of depositing rare-earth boride onto the surface of a substrate as in claim 1, in which the step of dissolving borane and at least one rare-earth halide in an organic solvent includes providing an organic solvent which includes at least one selection from the group consisting of:
   methanol
   THF;
   hexane;
   ether;
   benzene;
   nitriles; and amines.

3. A method of depositing rare-earth boride onto the surface of a substrate as in claim 1, in which the step of providing and placing a substrate in said solution of borane and at least one rare-earth halide in said organic solvent involves a substrate made of sodium glass.

4. A method of depositing rare-earth boride onto the surface of a substrate as in claim 1, in which the step of exposing the surface of said substrate to electromagnetic radiation involves use of a laser.

5. A method of depositing rare-earth boride onto the surface of a substrate as in claim 4, in which the favored wavelengths are in the visible range where \( \nu = 2.4 \) eV.

6. A method of depositing rare-earth boride onto the surface of a substrate as in claim 1, in which the step of exposing the surface of said substrate to electromagnetic radiation involves use of essentially white light which is passed through filtering means to provide favored wavelengths.

7. A method of depositing rare-earth boride onto the surface of a substrate as in claim 5, in which the favored wavelengths are in the visible range where \( \nu = 2.4 \) eV.

8. A method of depositing rare-earth boride onto the surface of a substrate as in claim 1, in which the step of exposing the surface of said substrate to electromagnetic radiation involves providing and placing an electromagnetic masking means between said source of electromagnetic radiation and the surface of said substrate.

9. A method of depositing rare-earth boride onto the surface of a substrate as in claim 1, in which the step of dissolving borane and at least one rare-earth halide in an organic solvent involves at least one rare-earth selected from the group consisting of:
   Sc;
   Y;
   La;
   Ce;
   Pr;
   Nd;
   Pm;
   Sm;
   Eu;
   Gd;
   Tb;
   Dy;
   Ho;
   Er;
   Tm;
   Yb; and
   Lu.

10. A method of depositing rare-earth boride onto the surface of a substrate as in claim 1, in which the step of dissolving borane and at least one rare-earth halide in an organic solvent involves chloride as the halide.

11. A method of depositing rare-earth boride onto the surface of a substrate as in claim 1, in which the step of exposing the surface of said substrate to electromagnetic radiation from a provided source of electromagnetic radiation causes formation of rare-earth hexaborides which deposit(s) on the surface of said substrate.

12. A method of depositing GdB onto the surface of a substrate comprising the steps of:
   a. dissolving \( \text{B}_n\text{H}_m \) and said GdCl\(_3\) in an organic solvent comprising methanol;
   b. providing and placing a substrate in said solution of \( \text{B}_n\text{H}_m \) and said GdCl\(_3\) in said organic solvent comprising methanol, so that a surface of said substrate is submerged, but accessible by electromagnetic radiation through said solution of \( \text{B}_n\text{H}_m \) and said GdCl\(_3\) in said organic solvent which includes at least one selection from the group consisting of:
   methanol
   THF;
   hexane; and ether;
c. providing a source of electromagnetic radiation and exposing the surface of said substrate to electromagnetic radiation through said solution of B₁₀H₁₄ and said GdCl₃ in said organic solvent comprising methanol, from said provided source of electromagnetic radiation; such that said GdCl₃ in the vicinity of said substrate surface is fragmented into free chloride and free Gd components, with the result being that said free chlorine fractures said B₁₀H₁₄, with the further result being that components of said fractured B₁₀H₁₄ combine with Gd to form GdBₓ⁺(B₁₀H₁₄Cl+yHCl), which GdBₓ deposits on said surface of said substrate.

13. A method of depositing rare-earth boride onto the surface of a substrate as in claim 12, in which the step of providing and placing a substrate in said solution of borane and at least one rare-earth halide in said organic solvent involves a substrate made of sodium glass.

14. A method of depositing rare-earth boride onto the surface of a substrate as in claim 12, in which the step of exposing the surface of said substrate to electromagnetic radiation involves use of a laser.

15. A method of depositing rare-earth boride onto the surface of a substrate as in claim 12, in which the step of exposing the surface of said substrate to electromagnetic radiation involves use of essentially white light which is passed through filtering means to provide favored wavelengths.

16. A method of depositing rare-earth boride onto the surface of a substrate as in claim 15, in which the favored wavelengths are in the visible range where hv=2.4 eV.

17. A method of depositing rare-earth boride onto the surface of a substrate as in claim 12, in which the favored wavelengths are in the visible range where hv=2.4 eV.

18. A method of depositing rare-earth boride onto the surface of a substrate as in claim 12, in which the step of exposing the surface of said substrate to electromagnetic radiation involves providing and placing an electromagnetic masking means between said source of electromagnetic radiation and the surface of said substrate.

19. A method of depositing rare-earth boride onto the surface of a substrate as in claim 12, in which the step of exposing the surface of said substrate to electromagnetic radiation from a provided source of electromagnetic radiation causes formation of rare-earth hexaborides which deposit(s) on the surface of said substrate.

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